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Document ID	Issue Date	Pages	Title	Current OR	Xref	Retrival C	Inventor	U	S	C	P	T	HTML
1 US 20040168926	20040302	7	Method and apparatus to deposit layers with uniform	205/137		205/117;	Basol, Bulent M. et al.	<input type="checkbox"/>					
A1			Method and apparatus for the electrochemical deposition	205/143;		205/117	Ismail, Ismail et al.	<input type="checkbox"/>					
2 US 20030132120	20030717		Method of providing conductive tracks on a	205/117		204/224R;	Lowe, John Michael	<input type="checkbox"/>					
A1			Method and apparatus for depositing and controlling	205/118		205/117	Izoh, Cyprian Emeka et al.	<input type="checkbox"/>					
3 US 2003024819	20030206		Method and apparatus for electrochemically depositing	205/117		204/224R;	Emesh, Ismail et al.	<input type="checkbox"/>					
A1			Method and apparatus for avoiding particle	205/117		205/117	Basol, Bulent M. et al.	<input type="checkbox"/>					
4 US 20020153256	20020204		Automated brush plating process for solid oxide fuel	205/117		205/117;	Long, Jeffrey William	<input type="checkbox"/>					
A1			Plating method and plating apparatus	205/117		204/224R;	Matsuda, Tetsuo et al.	<input type="checkbox"/>					
5 US 20020148732	20020107		Method and apparatus for vertically configured	205/117		204/228.1;	Volodarsky, Konstantin et al.	<input type="checkbox"/>					
A1			Chamber used for multiple	205/117		118/409;	118/730;	<input type="checkbox"/>					
6 US 20020139582	20020103		Packaging deposition methods	205/118		205/117;	Izoh, Cyprian Emeka et al.	<input type="checkbox"/>					
A1			Integrated plating and planarization process and	205/93		205/123;	Economikos; Laertis et al.	<input type="checkbox"/>					
7 US 20020139581	20020103		Method for electro-chemical mechanical deposition	205/93		204/224R;	205/117	<input type="checkbox"/>					
A1				205/117;		205/101;	Talih; Homayoun	<input type="checkbox"/>					
8 US 6676822	81	10		205/117;									
B1													

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